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(12) United States Patent

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(54) PHOTODEPOSITION OF METAL OXIDES FOR ELECTROCHROMIC DEVICES

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(58) Field of Classification Search

CPC . C03C 17/25; C03C 17/256; C03C 2218/116; C03C 17/32; G02F 1/1524;

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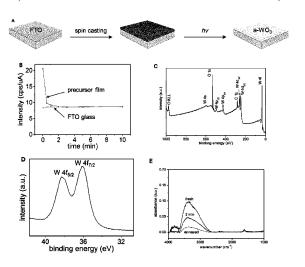
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(57) ABSTRACT

The present invention provides scalable, solution based processes for manufacturing electrochromic materials comprising metal oxide films for use in electrochromic devices. The electrochromic material comprises a transparent conductive substrate coated with an electrochromic metal oxide film, wherein the metal oxide film is formed by a process comprising the steps of: a) providing the conductive substrate; b) coating the substrate with a solution of one or more metal precursors; and c) exposing the coated substrate to near-infrared radiation, UV radiation and/or ozone in an aerobic atmosphere. The present invention also provides electrochromic devices incorporating these electrochromic materials.

20 Claims, 18 Drawing Sheets



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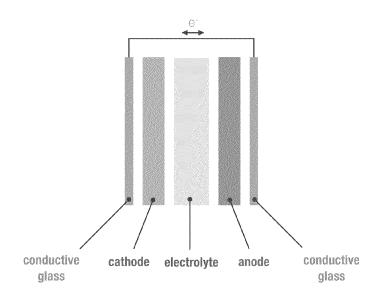
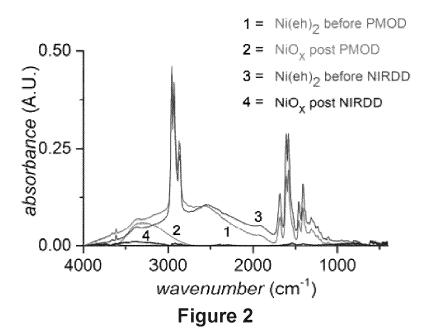


Figure 1



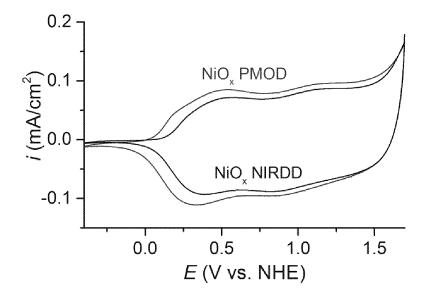


Figure 3

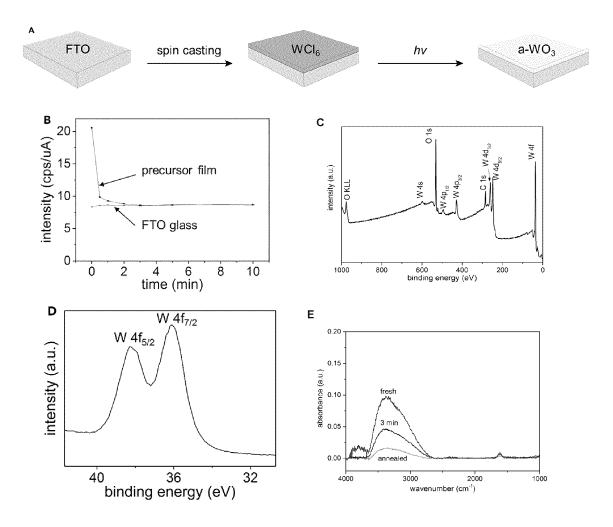


Figure 4

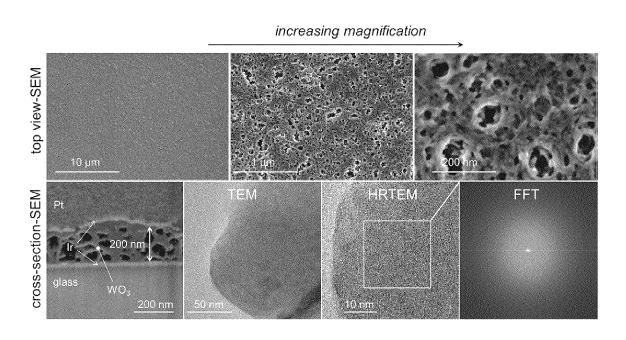


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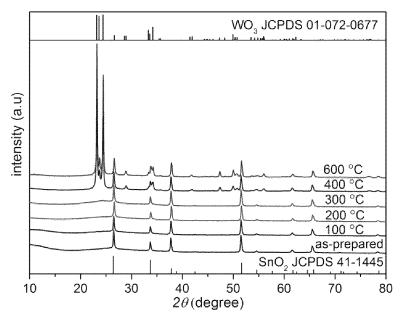


Figure 6

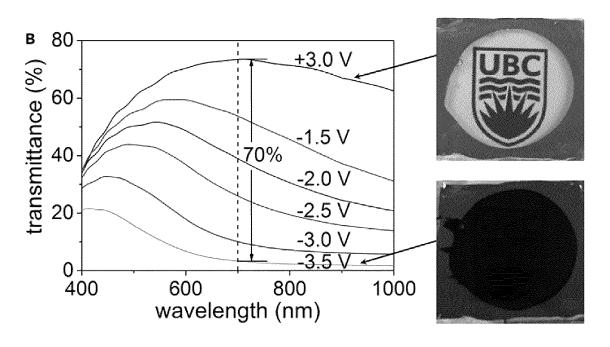


Figure 7

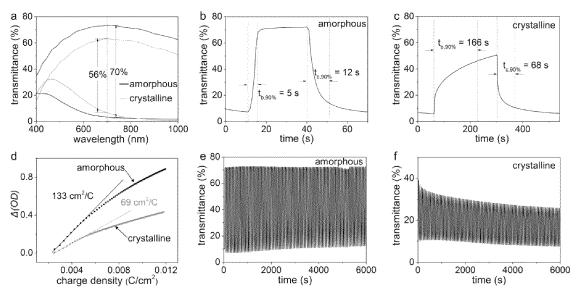
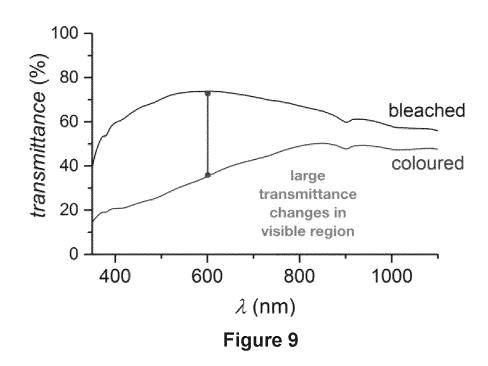
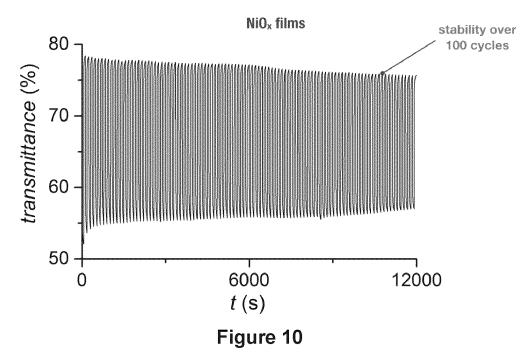


Figure 8





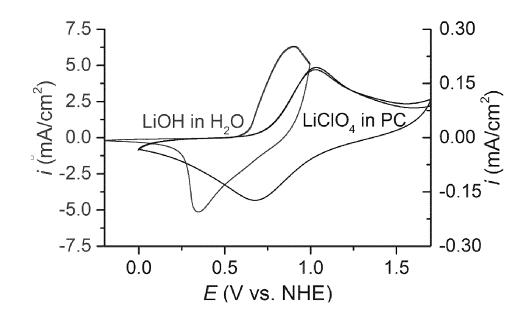


Figure 11

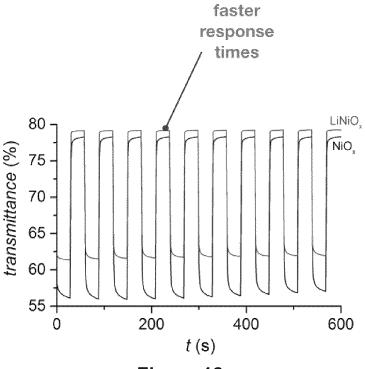


Figure 12

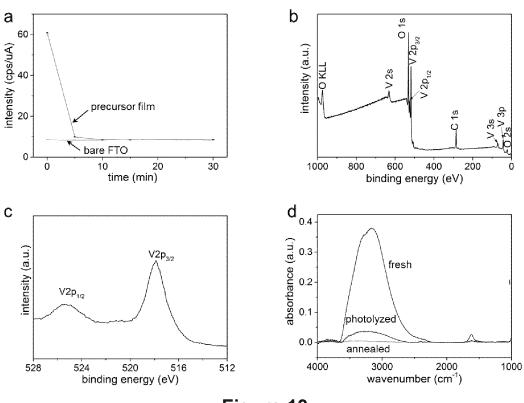


Figure 13

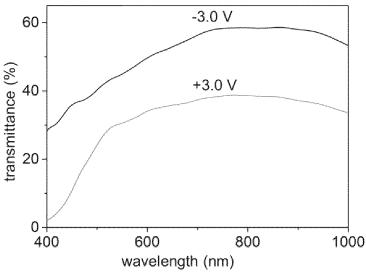
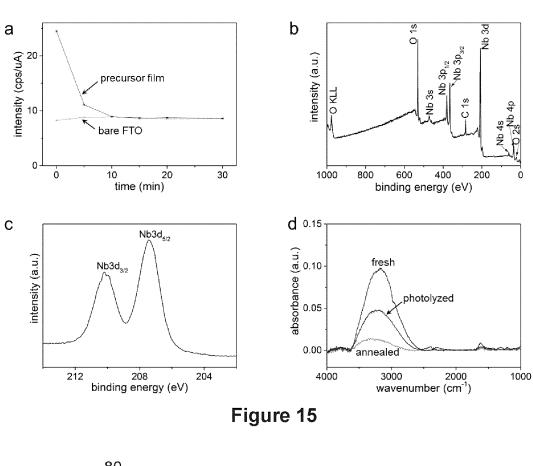


Figure 14



(%) 90 40 -4.0 V -4.0 V 40 600 800 1000 wavelength (nm) Figure 16

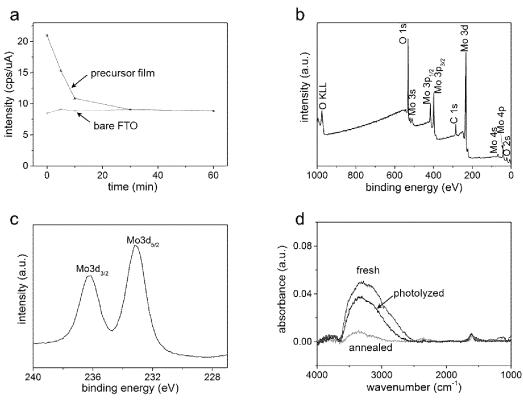


Figure 17

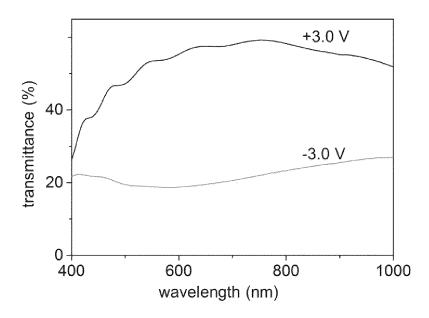


Figure 18

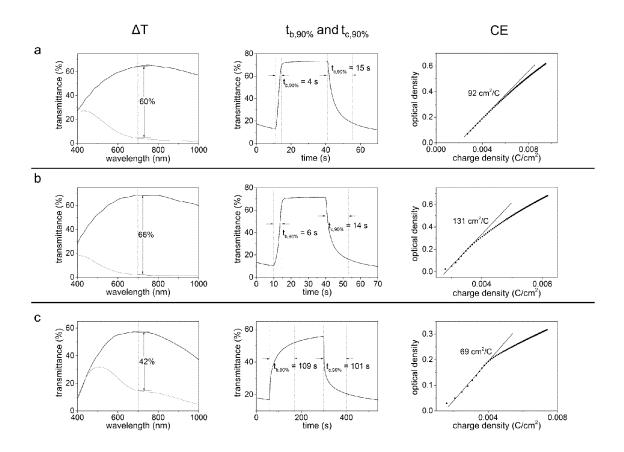


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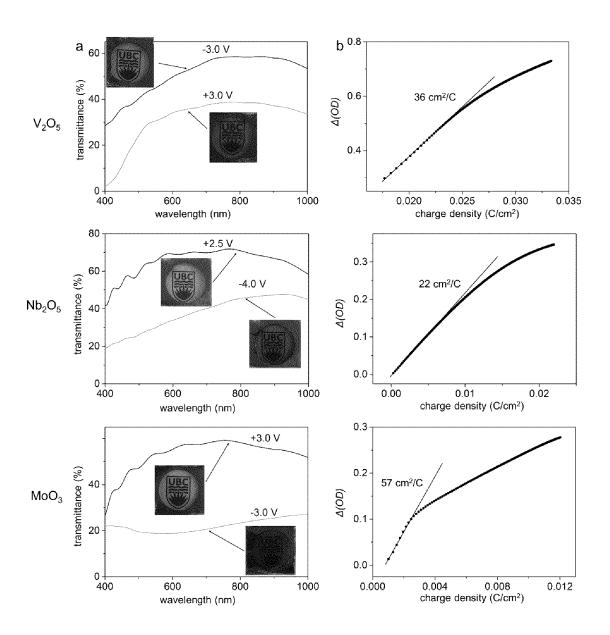


Figure 20

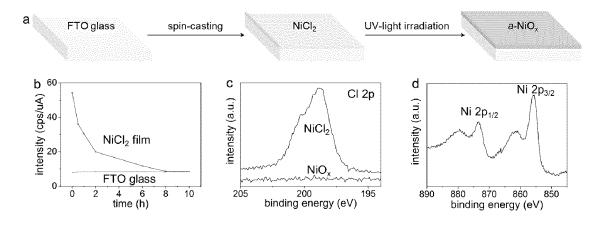


Figure 21

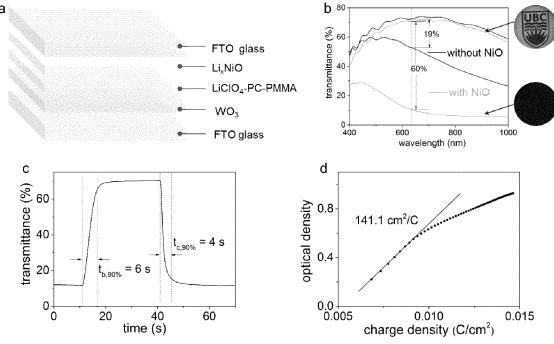


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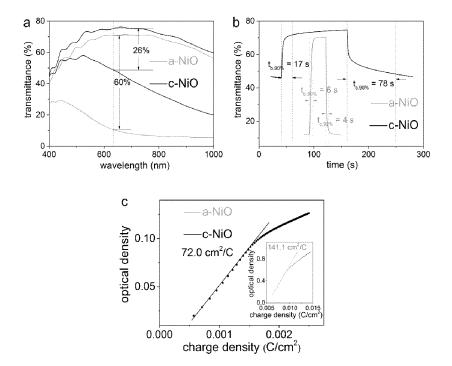


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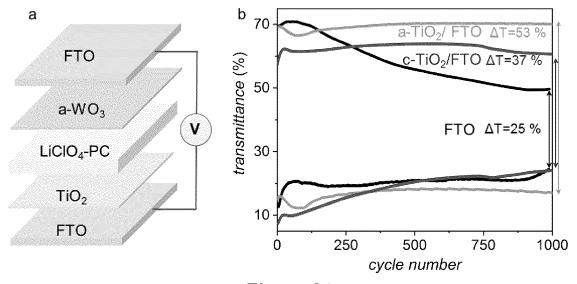


Figure 24

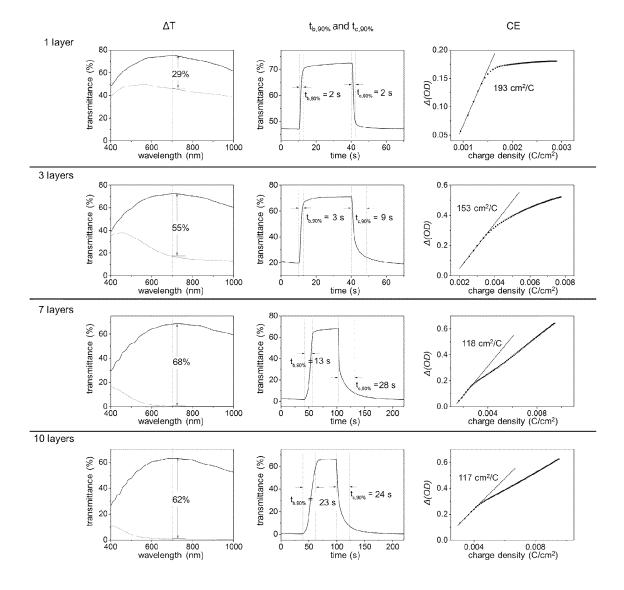


Figure 25

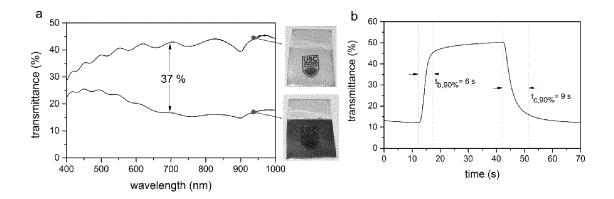


Figure 26

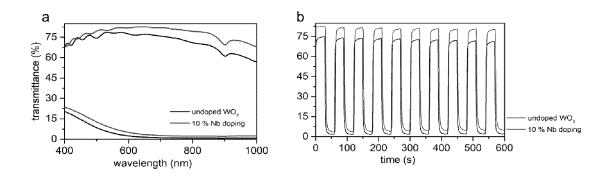


Figure 27

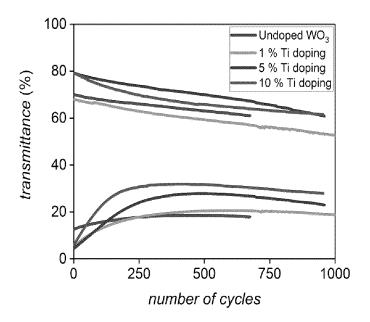


Figure 28

PHOTODEPOSITION OF METAL OXIDES FOR ELECTROCHROMIC DEVICES

CROSS-REFERENCE TO RELATED APPLICATIONS

This application is a national stage application under 35 U.S.C. § 371 of International Application No. PCT/CA2018/050885, filed Jul. 20, 2018, which claims the benefit of priority from U.S. Provisional Application No. 62/534,785, 10 filed Jul. 20, 2017. The disclosures of all of the above applications are incorporated by reference herein in their entireties.

FIELD OF INVENTION

The present invention relates to electrochromic films. More particularly, the present invention relates to processes for fabricating electrochromic metal oxide films for use in electrochromic devices.

BACKGROUND

Heating, ventilating, and air conditioning (HVAC) of buildings account for 30-40% of global primary energy 25 consumption. Altering the optical and thermal properties of windows can reduce the energy deficit of a building by up to 40%. It is therefore imperative to develop technologies to dynamically adjust the transmittance of windows to reduce the energy consumption of buildings, as the ability to 30 dynamically control window opacity to sunlight can provide the opportunity to reduce energy consumption by 20% and lighting costs by up to 50% for commercial buildings.

Electrochromic windows (also known as smart or dynamic windows) undergo changes in light transmittance 35 in response to an applied voltage, enabling dynamic control of the daylight and solar heat passing through buildings. Hence, this technology can provide indoor thermal and visual comfort for building occupants and also improve building energy efficiency. This energy-conservation technology has gained tremendous attention in industry, and in recent years, some glass companies have raised over 1 billion dollars to commercial electrochromic technology. Although large capital and efforts has been invested into this technology, the high price of electrochromic windows on the 45 market has prevented its widespread adoption as a building material.

A typical electrochromic (EC) device has a multilayer architecture consisting of active electrochromic layer, electrolyte layer, ion storage layer (counter electrode) layer, 50 transparent conductors and supporting substrates. Among these layers, electrochromic and ion storage layers are the key components contributing to the reversible color switching. Metal oxide layers may be employed as the active electrochromic layer and/or in the ion storage layer. The 55 most well-known electrochromic material coating used in the active electrochromic layer is WO₃, which can switch reversibly and persistently between dark blue and colorless states during the operation of the device.

Generating electrochromic metal oxide layers is therefore 60 a critical step in the manufacture of electrochromic cells. Sputtering is the most common technique used today to generate these electrochromic films, but this method requires vacuum and high temperatures energy to operate. Alternative techniques that have been tried to make these 65 layers include evaporation, chemical vapour deposition, electrodeposition, sol-gel techniques, laser ablation, sputter-

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ing and thermal deposition, but drawbacks such as cost, scalability, and obtaining the desired compositions have prevented these techniques from replacing sputtering as the industry standard.

There is therefore a clear need for an alternative metaloxide deposition process to the existing, onerous and expensive sputtering techniques that are commonly used to produce the electrochromic or light absorbing films.

SUMMARY OF INVENTION

An object of the present invention is to provide scalable, solution based processes for the photodeposition of metal oxides for use in electrochromic devices. In accordance with an aspect of the present invention, there is provided an electrochromic material for use in an electrochromic device, the electrochromic material comprising a transparent conductive substrate coated with an electrochromic metal oxide film, wherein the metal oxide film is formed by a process comprising the steps of: a) providing the conductive substrate; b) coating the substrate with a solution of one or more metal precursors; and c) exposing the coated substrate to near-infrared radiation, UV radiation and/or ozone in an 25 aerobic atmosphere to convert the one or more metal precursors to the metal oxide film on the conductive substrate, thereby forming the electrochromic material.

In accordance with another aspect of the present invention, there is provided an electrochromic device comprising:
(a) a first electrode comprising an electrochromic material prepared in accordance with the present methods, (b) a counter electrode, and (c) an ion-conductor layer for conducting ions between said first electrode and the counter electrode.

BRIEF DESCRIPTION OF THE FIGURES

FIG. 1 is a schematic depiction of an electrochromic cell and its components.

FIG. 2 depicts infrared spectra monitoring the decomposition of a nickel precursor into nickel oxide in accordance with a method of the present invention.

FIG. 3 depicts cyclic voltammograms of nickel oxide prepared by UV photodecomposition and NIRDD methods in accordance with the present invention.

FIG. 4a is a schematic depiction of the formation of the amorphous tungsten oxide films by solution depositing ethanolic solutions of WCl₆ on FTO glass followed by UV irradiation in accordance with the present invention.

FIGS. 4b-e depict the result of characterizing an amorphous tungsten oxide films prepared in accordance with the present invention, including (b) XRF analysis to determine chlorine content for WCl₆ on FTO glass, (c) and (d) XPS analysis of the metal oxide films on FTO glass, and (e) IR spectra of WCl₃ film of FTO glass before photolysis (fresh), after UV irradiation, and after annealing step.

FIG. 5 depicts electron micrographs of a-WO₃ films prepared in accordance with an embodiment of the present invention.

FIG. 6 depicts XRD diffractograms of a thin film of WO_3 on FTO glass annealed at progressively higher temperatures up to 600° C., prepared in accordance with an embodiment of the present invention.

FIG. 7 depicts transmittance data for the bleached and coloured states of a tungsten oxide film prepared in accordance with an embodiment of the present invention.

FIG. 8 depicts data relating to the electrochromic properties of amorphous and crystalline WO₃ prepared in accordance with an embodiment of the present invention.

FIG. **9** depicts transmittance data for the bleached and coloured states of nickel oxide prepared in accordance with ⁵ an embodiment of the present invention.

FIG. 10 is a plot depicting voltage cycling and stability over 100 cycles of nickel oxide films prepared in accordance with an embodiment of the present invention.

FIG. 11 depicts cycling voltammograms of nickel oxide films prepared in accordance with an embodiment of the present invention over in aqueous (H₂O) and non-aqueous solvents (PC—propylene carbonate).

FIG. 12 depicts transmittance data for nickel oxide and lithium nickel oxide films prepared in accordance with an embodiment of the present invention during cycling events.

FIG. 13 depicts data relating to the characterization of an amorphous vanadium oxide film prepared in accordance with an embodiment of the present invention, including (a) 20 XRF analysis to determine chlorine content for VCl₃ on FTO glass, (b) and (c) XPS analysis of the metal oxide films on FTO glass, and (d) IR spectra of VCl₃ film of FTO glass before photolysis (fresh), after UV irradiation, and after annealing step.

FIG. 14 depicts transmittance data for the bleached and colored states of vanadium oxide film prepared in accordance with an embodiment of the present invention.

FIG. 15 depicts data relating to the characterization of an amorphous niobium oxide film prepared in accordance with 30 an embodiment of the present invention, including (a) XRF analysis to determine chlorine content for NbCl₅ on FTO glass, (b) and (c) XPS analysis of the metal oxide films on FTO glass, and (d) IR spectra of NbCl₅ film of FTO glass before photolysis (fresh), after UV irradiation, and after 35 annealing step.

FIG. 16 depicts transmittance data for the bleached and colored states of niobium oxide film prepared in accordance with an embodiment of the present invention.

FIG. 17 depicts data relating to the characterization of an 40 amorphous molybdenum oxide film prepared in accordance with an embodiment of the present invention, including (a) XRF analysis to determine chlorine content for MoCl₅ on FTO glass, (b) and (c) XPS analysis of the metal oxide films on FTO glass, and (d) IR spectra of MoCl₅ film of FTO glass 45 before photolysis (fresh), after UV irradiation, and after annealing step.

FIG. 18 depicts transmittance data for the bleached and coloured states of molybdenum oxide film prepared in accordance with an embodiment of the present invention.

FIG. **19** depicts data relating to the determination of ΔT , $t_{b,90\%}$, and $t_{c,90\%}$ and CE of devices assembled with: (a) as-prepared WO₃; (b) WO₃ annealed at 200° C. in air for 1 hr; and (c) WO₃ annealed at 600° C. in air for 1 hr.

FIG. 20a depicts data relating to the optical transmittance 55 spectra for electrochromic devices containing V_2O_5 , Nb_2O_5 , or MoO_3 active layers, prepared in accordance with the present invention, (each annealed at 100° C.) in the colored and bleached states formed at the indicated potentials.

FIG. **20***b* depicts data relating to the change in $\Delta(OD)$ as 60 a function of charge density for electrochromic devices containing V_2O_5 , Nb_2O_5 , or MoO_3 active layers, prepared in accordance with the present invention.

FIG. 21a is a schematic depiction of the formation of the amorphous nickel oxide films by solution depositing ethanolic solutions of NiCl₂ on FTO glass followed by UV irradiation in accordance with the present invention.

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FIGS. 21b-d depicts the results of characterizing the NiO_x films prepared in accordance with the present invention, including (b) XRF analysis to determine chlorine content as a function of time, (c) and (d) XPS analysis of the metal oxide film on FTO glass.

FIG. 22a is a schematic depiction of the architecture of a solid state EC device using an NiO_x film on the FTO glass counter electrode as an ion storage material, prepared in accordance with an embodiment of the present invention.

FIGS. 22b-d depict the results of characterizing solid state devices employing an NiOx film on the counter electrode prepared in accordance with an embodiment of the present invention, including (b) a comparison of the transmittance spectra obtained for EC devices prepared with and without a-NiO $_x$ on the FTO glass counter electrode, (c) the transmittance change for the EC device prepared with a-NiO $_x$ on FTO as counter electrode as a function of time, and (d) changes in optical density at 633 nm as a function of charge density for a solid state EC device prepared using a-NiO $_x$ on the FTO glass counter electrode.

FIG. 23 depict the result of characterizing and comparing performances of EC devices using amorphous and crystal-line nickel oxides as counter electrodes, prepared in accordance with an embodiment of the present invention FIG. 24a is a schematic depiction of a device employing a TiO₂ film on the FTO glass counter electrode as an ion storage material, prepared in accordance with an embodiment of the present invention.

FIG. **24**b depict the results of characterizing and comparing EC devices employing a TiO₂ film on the FTO glass counter electrode as an ion storage material, including (b) maximum and minimum transmittance at wavelength of 700 nm over 1000 cycles for EC devices with WO₃ as the electrochromic layer, and a-TiO₂ (light grey) or crystalline c-TiO₂ (dark grey) deposited on FTO as the counter electrode, or without a TiOx film.

FIG. 25 depicts the results of characterizing WO₃ films of difference thicknesses prepared in accordance with the present invention.

FIG. 26 depicts transmittance data for a WO₃ film on tin-doped indium oxide (ITO) coated polyethylene terephthalate (PET), prepared in accordance with the present invention.

FIG. 27 depicts transmittance data for undoped WO₃ and Nb-doped WO₃ films on FTO glass, prepared in accordance with the present invention.

FIG. 28, depicts transmittance data for undoped WO₃ and Ti-doped WO₃ films on FTO glass prepared in accordance with the present invention

DETAILED DESCRIPTION OF THE INVENTION

Definitions

"Amorphous" means a chemical composition without long-range order in its atomic structure.

"Electrochromic cell" refers to a cell that is capable of transitioning transparency from a colored state (i.e., low transmittance of light through the window) to a transparent state (i.e., high transmittance of light through the window), and/or from a transparent state to a colored state, through the use of an applied electrical bias. The "transparent" state may also be referred to as a "bleached" state.

"Ligand" means any chemical group coordinated, chemically bonded or ionically bonded to a metal. Typical ligand

examples are, but not limited to, chloride, bromide, nitrate, 2-ethylhexanoate and acetylacetonate.

"Metal Oxide" may refer herein to any single solid containing a metal and oxygen, where the ratio of metal to oxygen is undefined and therefore represented as MO_x. 5 Examples of single metal oxides that may be suitable for use as an electrochromic material include, but are not limited to, NiO₂, WO₃, MoO₃, TiO₂, Ta₂O₅, V₂O₅, Nb₂O₅, COO₂, MnO_2 , and FeO_x .

"Mixed Metal Oxide" refers to a film that contains at least 10 two metals and is an oxide. Examples of mixed metal oxides that may be suitable for use as an electrochromic material include, but are not limited to, LiNiO_x, TiWO_x, and FeNiO_x.

"Metal Precursor" describes any chemical containing a metal that is deposited onto a substrate and then converted 15 into a metal oxide. Typical examples include, but are not limited to, metal chloride, metal 2-ethylhexanoate and metal acetylacetonate, wherein the metal may be any of the metals identified above.

iron and oxygen are present in nearly equal amounts.

"Sputtering" refers to a technique whereby a pure metal is exposed to high energy that ejects atoms of the metal into a medium with the atoms subsequently being deposited onto a substrate.

"Substrate" refers to the material upon which the metal oxide coating is assembled. The substrate material may be inherently conductive, or the conductivity may be engendered through application of a conductive film to the surface of the material. A suitable film typically comprises a trans- 30 parent conductive oxide (TCO) such as fluorine tin oxide (FTO); indium tin oxide (ITO); aluminum zinc oxide (AZO) and various others. Other suitable support materials include any transparent glasses, plastics, polymers (e.g. PET), or rubbers compatible with a relevant conductive layer.

This present invention relates to electrochromic devices comprising electrochromic metal oxide and/or mixed-metal oxide films produced using scalable fabrication processes which do not require a vacuum, and which may be carried out at an ambient or elevated temperature.

An objective of the present invention is therefore to provide low cost, scalable, solution based processes for manufacturing an optical quality film of a metal oxide or mixed metal oxide coated on a suitable conductive substrate, for use in an electrochromic device. In accordance with the 45 present invention, the metal oxide and/or mixed metal oxide films formed using the present processes are electrochromic, i.e., capable of transforming its transparency from the colored state to a transparent state (or transparent state to a colored state) upon the introduction of an external electrical 50

The invention further provides photochemical methods suitable for the large-scale processing and manufacturing of the desired metal oxide and mixed metal oxide films, in amorphous or crystalline phases, for use in the electrochro- 55 mic devices of the present invention.

The present disclosure describes two methods suitable for making metal oxides and mixed metal oxides for electrochromic devices: Near Infrared Driven Decomposition (NIRDD) or UV photodecomposition. Both NIRDD and UV photodecomposition are methods of manufacture that operate at lower temperatures with solution processable precursors that afford precise composition control and lower cost manufacturing than existing state-of-the-art techniques.

In one embodiment, there is provided a Near-Infrared 65 Driven Decomposition (NIRDD) method, which uses infrared light to decompose a metal precursor to generate the

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corresponding metal oxide or mixed metal oxide, if formed in the presence of air. PCT Patent Publication No. WO2016101067 A1 describes an NIRDD method for the preparation of metal oxides and mixed-metal oxides, the entire disclosure of which is incorporated herein by refer-

In one embodiment, there is provided a UV photodecomposition method, in which the metal precursor is subjected to ultraviolet radiation, optionally in the presence of ozone, to remove all ligands and produce the desired metal or mixed-metal oxides under aerobic atmosphere. UV photodecomposition operates at either ambient or elevated temperatures. U.S. Pat. No. 9,433,928 describes a UV photodecomposition technique for generating metal oxides and mixed-metal oxides for use in methods for making electrocatalysts, the entire disclosure of which is incorporated herein by reference.

When carried out on a metal precursor in the absence of "Reduced Iron Oxide" refers to the compound FeO where 20 air, both UV photodecomposition and NIRDD can result in a more reduced phase of the corresponding metal.

> The electrochromic metal oxide and/or mixed-metal oxide films formed using the methods of the present invention may be amorphous or crystalline.

> In one embodiment of the present invention, the metal oxide or mixed metal oxide is formed on a transparent conductive oxide layer and subsequently incorporated into an electrochromic cell that is capable of transitioning from opaque to transparent or transparent to opaque through the use of an applied electrical bias.

> In accordance with the present invention, one or more metal or mixed metal oxide coatings are employed as layers in an electrochromic cell that are incorporated into "smart glass" applications such as electrochromic windows.

The general configuration of an electrochromic device comprises an anode and cathode supported on transparent conductive substrates and an inter-electrode ion conductor (electrolyte). The anode and/or the cathode may comprise electrochromic material(s). The function of each component 40 of the overall device is described in detail below, and a schematic depiction of the overall device architecture is presented in FIG. 1.

When a voltage is applied across the electrodes, an electric field is generated within the insulating electrochromic material, which can cause migration of ions to or from the electrochromic material producing colour changes in that electrochromic material (e.g., from bleached to colored when switched from one electrochromic state to another). By reversing the applied bias, the electrochromic material can be switched back (e.g., from colored to bleached state). The electrochromic material may also be colored initially, and switch to a colorless/bleached state with applied voltage, and then switched back to the colored state by reversing the applied bias. For example, tungsten oxide based films colour with ion insertion, whereas nickel oxide based films colour with ion extraction.

The role of the electrolyte layer in an electrochromic cell is to allow ions to travel between the anode and cathode materials. An example of a common electrolyte for electrochromic devices is LiClO₄ in propylene carbonate.

As such, a typical electrochromic device has a multilayer architecture consisting of active electrochromic layer, electrolyte layer, ion storage layer (counter electrode) layer, transparent conductors and supporting substrates. Among these layers, electrochromic and ion storage layers are the key components contributing to the reversible color switch-

A good electrochromic material exhibits a high colour contrast between its coloured and bleached states, has rapid conversion between coloured and bleached states, is capable of switching between colored and bleached at low applied voltage, shows excellent reversibility with cycling between 5 states, and excellent stability.

In accordance with preferred embodiments of the present invention, the metal oxide and mixed-metal oxide films employed in the electrochromic devices comprise NiO_x, WO_x, NbO_x, MoO_x, MnO_x, CoO_x, VO_x, TaO_x, TiO_x and 10 LiNiO_x, or combinations thereof.

Another application for the metal or mixed metal oxide is to provide coatings on windows that preclude the entry of long wavelength solar radiation, alone or in combination with the electrochromic metal oxide coatings. In one 15 embodiment, the light absorbing coating is provided by a reduced iron oxide film. The reduced iron oxide may be produced by either NIRDD or UV photodecomposition in an inert atmosphere such as nitrogen or argon. In all of these embodiments, a reduced iron oxide layer may be incorporated to block near-infrared light without affecting visible light, thereby serving to absorb near-infrared wavelengths while allowing visible light to pass through.

The most well-known electrochromic material coating that comprises the working electrode is WO_3 film that 25 switches reversibly and persistently between dark blue and colorless states during the operation of the device.

Tungsten trioxide ("WO₃") is a well known cathodic electrochromic material that cycles between a pale yellow (or transparent) neutral and deep blue reduced state in 30 electrochromic devices. The transparent film can be electrochemically reduced in the presence of lithium ions to form the colored, reduced state ("LiWO₃"), and reversibly re-oxidized to the transparent state. The methods of the present invention can be used to form WO_x films for use in 35 the electrochromic devices.

Examples of other electrochromic cathodic materials include, but are not limited to, MoO_3 , TiO_2 , Ta_2O_5 , V_2O_5 , NiO_3 , and Nb_2O_5 .

Nickel oxide ("NiO_x") is a known anodic electrochromic 40 material that colours complementary to tungsten oxide to create a better colored dark state in the electrochromic cell. The methods of the present invention can be used to form NiO_x films for use in the electrochromic devices.

Another example of a good anodic electrochromic mate- 45 rial is IrO₂. Materials such as CoO₂, MnO₂ and FeO₂ have also been shown to exhibit electrochromic behavior, but are not ideal as they do not bleach completely.

Iron oxide ("FeO") is a material known for a high absorption of near-infrared light relative to visible light. It 50 can be used for coatings on architectural glass to reduce interior solar heating of buildings. Thin films of FeO can be created by sputtering, or chemical vapor deposition under anoxic conditions.

Transparent conductive metal oxides (TCOs) such as tin 55 doped indium oxide (ITO) and fluorine doped tin oxide (FTO) are frequently used as counter electrodes in isolation or coated with additional ion storage materials. Although devices with bare TCO for their counter electrode usually show better transparency in the bleached state, in such 60 devices the charge is usually not balanced between the two electrodes, which may be detrimental to the device stability. The methods of the present invention can be used to form a stabilizing metal oxide ion storage layer.

A metal precursor or combination of metal precursors 65 is/are coated onto a substrate that may include, but is not limited to, glass, plastic, composites, etc. In an embodiment

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of the present invention, the preferred substrate is transparent and is either glass or plastic.

Coating the chosen substrate can be performed using a variety of methods including spin coating, painting, dip coating, spray coating, ultra-sonic spray coating or other methods familiar to those skilled in the art. A coating solution is prepared by dissolving the metal precursor or precursors into a compatible solvent and then applying the solution to the surface of the substrate. Upon drying, a layer of the desired precursor or precursors is formed on the substrate. Examples of compatible solvents include but are not limited to water, methanol, ethanol, isopropanol, acetone, hexane, acetylacetone, and methyl isobutyl ketone.

Metal precursors suitable for use in the processes of the present invention include any metal derivative that can be converted to the corresponding metal oxide upon exposure to near-infrared radiation, UV radiation and/or ozone. Suitable precursors include, but are not limited to, metal chlorides, metal 2-ethylhexanoate and metal acetylacetonates. Exemplary embodiments of metal precursors include WCl₆, Ni(eh)₂, NiCl₂, VCl₃, NbCl₅, MoCl₅, Li(eh), W(O-iPr)₆ and Ti(eh)₄.

Either the NIRDD and/or UV photodecomposition method can be used to convert the metal precursor that is coated onto the substrate to the desired amorphous or crystalline metal oxide or mixed-metal oxide in air at ambient or elevated temperature. Forming a mixed-metal oxide using the sputtering technique is comparatively more onerous.

In one embodiment of the synthesis of a metal oxide film, a precursor solution is produced by dissolving the metal precursor in anhydrous ethanol. The precursor solution is then spin-coated on FTO glass, and the resultant precursor thin films are subjected to UV or NIR irradiation until decomposition is confirmed through monitoring of ligand loss using spectroscopic methods. To produce multi-layer thin films, the spin-coating and irradiation steps are repeated multiple times.

In certain embodiments, the as-deposited films undergo an annealing step in an oven in air at temperatures ranging from $50\text{-}750^\circ$ C. for 1 hour using a ramping rate of 10° C./min. In one embodiment, the films undergo an annealing step at 100° C. for 1 hour. In one embodiment, the films undergo an annealing step at 200° C. for 1 hour. In one embodiment, the films undergo an annealing step at 200° C. for 1 hour. In one embodiment, the films undergo an annealing step at 200° C. for 1 hour.

For precursors comprising organic ligands, formation of the desired metal oxide can be monitored by infrared spectroscopy, as loss of ligands from the metal precursor gives rise to a loss of ligand signal in the infrared spectrum. FIG. 2 depicts the transformation from the nickel 2-ethylhexanoate metal precursor to amorphous nickel oxide using both the UV photodecomposition and NIRDD methods.

For precursors which cannot be tracked by infrared spectroscopy, including but not limited to metal chloride salts, X-ray fluorescence (XRF) spectroscopy can be used to monitor the transformation to amorphous metal oxide.

In accordance with the present invention, both the NIRDD and UV photodecomposition methods can be used to produce the same final metal oxide films. FIG. 3 depicts the cyclic voltammetry of nickel oxide films produced using both the NIRDD and UV photodecomposition methods of the present invention. Both voltammetry curves depict the same shape and features indicating that the amorphous metal oxide films generated by NIRDD and UV photodecomposition are electrochemically the same.

The following performance metrics were evaluated for the devices formed using metal oxide films prepared using the methods of the present invention: (i) maximum optical modulation (Δ T), the difference of light transmittance between fully colored and bleached states; (ii) switching time for coloring ($t_{c,90\%}$) and bleaching ($t_{b,90\%}$) required to reach 90% of full change of transmittance between the respective fully colored and cleared states; and (iii) coloration efficiency (CE), which corresponds to the change in optical density (Δ (OD)) in response to the change in charge per unit area (Δ Q). The value of CE was acquired by fitting the linear region in the plot of Δ (OD) as a function of Δ Q, and extracting the slope in accordance with Eq. 1 (where T_b and T_c are the transmittance in the bleached state and colored states, respectively, at a given wavelength).

$$CE = \frac{\Delta(OD)}{\Delta Q} = \frac{\log \left(\frac{T_b}{T_c}\right)}{\Delta Q} \tag{Eq. 1} \label{eq:eq.1}$$

In one embodiment, amorphous tungsten oxide films produced in accordance with the methods of the present invention exhibit electrochromic properties suitable for use 25 in electrochromic devices. FIG. 4a is a schematic depiction of the formation of the amorphous tungsten oxide films by solution depositing ethanolic solutions of WCl₆ on FTO glass followed by UV or NIR irradiation in accordance with the methods of the present invention.

Amorphous tungsten oxide formed using NIRDD or UV photodecomposition shows broad transmittance in bleached mode (35-75%) and a reduced transmittance in colored mode (5-20%) over the entire visible spectrum as depicted in FIG. 7. The amorphous WO₃ films demonstrated voltage-controlled light transmittance over the visible and infrared range (400-1000 nm). The transparency of the tungsten oxide film can be precisely manipulated by controlling the applied bias. Upon introduction of a positive bias the bleached state is generated and transmittance increases. 40 Application of a negative bias generates the coloured state and light transmittance is decreased through the tungsten oxide (FIG. 7).

In one embodiment, amorphous nickel oxide films formed using the NIRDD and UV photodecomposition methods of 45 the present invention also exhibit electrochromic properties suitable for use in electrochromic devices. Upon introduction of a positive bias, the colored state is generated and transmittance decreases. Application of a negative bias generates the bleached state and light transmittance is increased 50 through the nickel oxide. The transparency of the nickel oxide film can be precisely manipulated by controlling the applied bias. A full spectrum transmittance curve for both bleached and colored modes of a nickel oxide film prepared in accordance with the present invention is shown in FIG. 9. 55 Under colored conditions the transmittance ranges from 15-45%, while in bleached mode the transmittance is between 40-70%. Amorphous nickel oxide formed by either the UV photodecomposition or NIRDD methods of the present invention exhibits long-term stability cycling 60 between colored and transparent modes as depicted in FIG. 10. Samples cycled over a time period of 12000 s (100 cycles) repeatedly return to within 5% of their transmittance levels after each individual cycle.

The electrolyte/ion conductor between the anode and 65 cathode materials can be modified to impart desired transparency, conductivity and durability properties. Amorphous

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nickel oxide films formed using the methods of the present invention provide additional flexibility for electrochromic device design by operating successfully in both aqueous and organic electrolytes. Cyclic voltammetry curves shown in FIG. 11 reveal repeatable, reversible oxidation and reduction peaks in aqueous and non-aqueous solvents demonstrating the stability of the amorphous nickel oxide layer.

Mixed metal oxides have been shown in other applications (e.g. superconductors, electrolysis) to achieve superior performance with respect to individual metal oxides. This improvement in performance is achieved through synergistic and energetic effects at the atomic and nanoscale. For the present invention lithium was introduced into the amorphous nickel oxide film in a ratio of 1:3. The mixed metal oxide film LiNi $_3$ O $_x$ achieves steady-state electrochromism much faster (by seconds) than the amorphous nickel oxide as depicted in FIG. 12. Faster steady-state electrochromism is advantageous for commercial applications, especially those requiring rapid transitions of the electrochromic cell from opaque to transparent.

The generality of the presently methods for making electrochemically active oxide layers was extended to amorphous films of V₂O₅, Nb₂O₅, and MoO₃ derived from VCl₃, NbCl₅, and MoCl₅, respectively. The electrochromic devices containing V₂O₅, Nb₂O₅, and MoO₃ each showed optical modulation in the visible range with at 20%, 30%, and 35%, respectively at wavelengths of 700 nm (FIG. 14, 16, 18, respectively). Larger changes in transmittance were observed at different wavelengths. XPS analyses of each of the as-prepared oxide films confirmed the absence of chlorine and the stabilization of the respective metals (vanadium, niobium, or molybdenum) in their fully oxidized chemical states (FIGS. 13a, 15a and 17a, respectively). The asprepared V_2O_5 , Nb_2O_5 , and MoO_3 thin films contained residual water that was effectively removed by further annealing for 1 hour at 100° C. (FIGS. 13d, 15d and 17d, respectively). The electrochromic devices containing V₂O₅, Nb₂O₅, and MoO₃ each showed optical modulation in the visible range with coloration efficiencies of 36, 22, and 57 cm²/C at wavelengths of 450, 500, and 550 nm, respectively (FIG. 20). FIG. 20a depicts the optical transmittance spectra for electrochromic devices containing three V₂O₅, five Nb₂O₅, or five MoO₃ active layers (each annealed at 100° C.) in the colored and bleached states formed at the indicated potentials. FIG. 20b depicts the plots of $\Delta(OD)$ for V_2O_5 at 450 nm, Nb₂O₅ at 550 nm, and MoO₃ at 550 nm as a function of charge density. The CE values obtained by fitting the linear region of each plot are also indicated in FIG. 20b.

FeO films produced by UV decomposition and NIRDD show a strong absorbance in the near-infrared region while remaining transparent to visible light. A FeO film applied to an electrochromic device will block near infrared light regardless of the state of the device, either on or off.

Table 1 compares the CE of various electrochromic metal oxides prepared via different methods. In all cases, the methods described herein provide metal oxide films that are similar, or better than, the films made by other methods.

TABLE 1

Electrochromic performance parameters for cathodic electrochromic films.						
Active layer	Description	Preparation method	CE (cm ² /C)	Wavelength ^a (nm)	Ref	
Amorphous WO ₃	600-nm amorphous film	photodeposition	133	700	this work	
Crystalline WO ₃	600-nm crystalline film	photodeposition	69	700	this work	
WO_3	amorphous film	electrochemical deposition	62	630	Srivastava et al. (2005)	
WO ₃ •2H ₂ O	crystalline nanosheets	chemical solution	121	700	Liang et al. (2013)	
WO_3	crystalline nanowires	hydrothermal	103	630	Zhang et al. (2011)	
WO_3	crystalline mesoporous	chemical condensation	40	630	Brezesinski et al. (2006)	
V_2O_5	amorphous film	photodeposition	36	450	this work	
V_2O_5	crystalline	electrochemical deposition	36	430	Scherer et al. (2012)	
V_2O_5	crystalline nanofibers	electrochemical deposition	32	450	Tong et al. (2015)	
Nb ₂ O ₅	amorphous	photodeposition	22	500	this work	
Nb ₂ O ₅	amorphous	chemical condensation	29	500	Llordes et al. (2016)	
Nb_2O_5	amorphous	thermal condensation	15	500	Llordes et al. (2016)	
MoO_3	amorphous	photodeposition	57	550	this work	
MoO ₃	amorphous	chemical vapor deposition	26	550	Maruyama et al. (1995)	
MoO ₃	crystalline nanoparticles	sol-gel	24	550	Hsu et al. (2008)	

^aWavelength at which optical data for CE values were recorded.

The methods of the present invention can also be used to deposit a metal oxide film as an ion storage layer on the counter electrode. Ion storage material coated on a TCO substrate can efficiently balance the charges generated by the working electrode (typically WO₃) during operation by 35 storing Li-ions during device bleaching and releasing Liions that intercalate into the WO3 during colouration. NiO and IrO₂ are the commonly used ion storage materials in EC devices, and can improve colouration intensity by providing complementary colouration for the EC devices. However, due to the intrinsic colour of NiO and IrO2, the optical modulation value may be compromised. While is the use of an optically passive ion storage materials such as CeO2 can preserve the transparency of the device in the bleached state, its ion storage capacity is limited. It is therefore highly desirable to seek alternative optically passive counter electrode materials that also demonstrate outstanding ion storage capacity. TiO2 exhibits excellent lithium ion storage capability when used as an anode material in lithium ion batteries, indicating that TiO2 thin films can be used as ion-storage materials for application on the counter electrodes of EC

In one embodiment, an amorphous ${\rm TiO_2}$ film prepared in accordance with the methods of the present invention is employed as a counter electrode material for use in EC devices.

In one embodiment, an ion storage metal oxide film is coupled to a photodeposited electrochromic film prepared in accordance with the present invention to form a solid state electrochromic device that shows state-of-the art electrochromic performances. Solid-state electrochromic devices can avoid the safety and sealing issues existing in a device using liquid electrolyte.

The invention will now be described with reference to specific examples. It will be understood that the following examples are intended to describe embodiments of the invention and are not intended to limit the invention in any way.

EXAMPLES

Example 1: NiO_x UV Photodecomposition

In this example, fluorine-doped tin oxide (FTO; TEC 7; 7 Ω /sq) substrates are cut into 2.5 by 2.5 cm squares and cleaned with sonication in Extran® 300 detergent for 15 minutes, deionized H₂O for 15 minutes, acetone for 15 minutes, exposed to UV light with $O_{3(g)}$ for 20 minutes and spin coated. The precursor solution is a photoactive nickel compound. In this example, nickel (II) 2-ethylhexanoate (78% (w/w) in 2-ethylhexanoic acid, Strem Chemicals) was used. A 0.2 M solution in ethanol was prepared and applied to the clean FTO surface. The sample was spin-coated (3000 rpm, 60 s) to yield a thin film of nickel (II) 2-ethylhexanoate. The coated substrates were then exposed to UV radiation. In this example, the samples were placed under a dual wavelength UV lamp (I=185, 254 nm) for 24 hours. Precursor decomposition was monitored by infrared (IR) spectroscopy and was considered complete when stretches corresponding to the corresponding ligand have disappeared.

Example 2: NiO_x NIRDD

In this example, the same precursors are applied to the same substrates and spin-coated in the same manner as Example 1. In this case, the samples are placed under an infrared lamp to induce precursor decomposition to form an a-NiO $_x$ film. The films formed are transparent following decomposition. The precursor decomposition can be tracked in the same manner as in Example 1.

Films prepared in accordance with the present methods (including those formed in Examples 4 to 15) were incorporated into electrochromic devices fabricated by placing a 5 2×2 cm square silicone rubber sheet (20 A, thickness=1 mm; McMaster-CARR) with a centered hollow circle (diameter=1.6 cm) on top of a bare FTO glass that serves as the counter electrode. FTO glass was then coated with the electrochromically active metal oxide films (working elec- 10 trode) laid on top the silicon spacer to form a closed cell. Epoxy glue was used to seal three sides of the cell. A 1-M LiClO₄ propylene carbonate electrolyte solution was injected into the cell by a syringe through the unsealed side. Prior to injection, the empty cell and the electrolyte in a vial were purged with dry N₂ for 5 min respectively to drive away ambient air. Sealing the fourth side with epoxy glue provided the final electrochromic device. The assembled device had an active area of 2.0 cm².

Example 4: WO₃ UV Photodecomposition

In this example, the transparent conductive oxide was prepared in the same manner as Example 1. Anhydrous ethanol is added to tungsten (VI) chloride (WCl₆, Sigma- 25 Aldrich) to make a 0.25 M solution. This solution was stirred for 16 hours and spin-coated onto a substrate (3000 rpm, 60 s) yielding a dark blue film on the substrate. The substrate was then placed under a UV lamp (I=185 or I=185, 254 nm) for decomposition of the precursor to form a-WO₃. Trans- 30 formation to the metal oxide was monitored by X-ray fluorescence. The electrochromic devices were assembled as described in Example 3, with 600-nm films of WO₃ films (corresponding to 5 sequential depositions of the tungsten precursor) on FTO glass as the working electrode. The 35 amorphous WO₃ films in the devices (denoted as a-WO₃) were annealed at 100° C. for 1 hr prior to being placed in the device to suppress delamination from the substrate.

FIG. 4b shows the results of the XRF monitoring of the chlorine content for WCl₆ on FTO glass as the chloride 40 precursor decomposes during UV photodecomposition for tungsten, and confirm by XRF analysis complete decomposition of the precursor within 3 min of UV irradiation. FIGS. 4c and 4d show that the XPS analysis of the metal oxide films on FTO glass is consistent with the formulation of 45 WO₃ given the presence of W4f spectral signatures consistent with W⁶⁺. FIG. 4e depicts the IR spectra of WCl₆ dissolved in ethanol spin-cast on FTO glass before and after being subjected to UV irradiation for 3 min, as well as the IR spectrum recorded on a layer of WO₃ formed after 50 exposure to UV light for 3 min and annealed at 100° C. for 1 hr.

FIG. 5 depicts the SEM, TEM, and HRTEM characterization of a single WO₃ layer prepared in accordance with the UV irradiation method of the present invention, and 55 annealed for 1 hr at 100° C. The electron micrographs of FIG. 5 show uniform, high-porosity, amorphous films with thicknesses of 200 nm. The iridium and platinum layers shown in the cross-sectional SEM image were deposited to reduce charging effects by increasing film conductivity and 60 to protect the underlying film from the focused ion beam used to create the cross section.

The amorphous nature of the WO_3 thin films was further supported by XRD diffractograms that show no evidence of crystalline phases other than the FTO substrate (FIG. 6). The 65 films were annealed in 100° C. steps from 100-600° C. for 60 min each. The presence of a crystalline phase, namely

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monoclinic WO_3 , was only detected when the films were heated above 400° C. The crystalline WO_3 films display electrochromic properties also.

Example 5: Comparison of the Electrochromic Properties of Amorphous and Crystalline WO₃

The effects of annealing on amorphous WO₃ film produced in Example 4 were investigated. The benchmark crystalline film (denoted as c-WO₃) was prepared following the same protocol described in Example 4, but with an additional 1 hr annealing step at 400° C.

Optical transmittance spectra of the devices under coloring and bleaching biases show that the change in transmittance value of ~70% measured at 700 nm for the amorphous WO₃ is ~15% higher than the values measured for the crystalline WO₃ (FIG. 8a). The transmittance change at 700 nm when the device is switched from colored to bleached back to colored for devices containing amorphous and 20 crystalline films is shown in FIGS. 8b and 8c, respectively. Switching times are indicated. The switching time of coloring (t_{c.90%}, defined by the time required to reach 90% of full change of transmittance from clear to colored state) (12 s) and the switching time of bleaching from colored to clear state $(t_{b.90\%})$ (5 s) values measured for amorphous WO₃ (FIG. 8b) were markedly faster than those for crystalline WO_3 , which show $t_{c,90\%}$ and $t_{b,90\%}$ values that are 5- and 35-fold longer, respectively (FIG. 8c). FIG. 8d depicts changes in optical density ($\Delta(OD)$) at 700 nm as a function of charge density. CE values were determined by fitting the linear region of the plot. The colouration efficiency (CE) of the amorphous WO₃ was calculated to be 133 cm²/C at a wavelength of 700 nm, which is almost twice that of crystalline WO₃ (FIG. 8d). FIGS. 8e and 8f depict the transmittance change at 700 nm during the electrochromic switching between colored and bleached states for 100 cycles in 30 s steps. The stability of amorphous WO₃ (formed by either UV photodecomposition or NIRDD) over 1000 cycles of switching the applied bias from -3.5 V for 30 s to 3.0 V for 30 s confirmed that 90% of the initial transmittance change was retained (FIG. 8e). There is almost negligible degradation in the initial 100 cycles of the amorphous oxide (FIG. 8e), however, the transmittance change for the crystalline tungsten oxide showed significant degradation over the same 100 cycles (FIG. 8f).

Example 6: Effect of Annealing Temperature on Electrochromic Performance

An amorphous WO₃ film was prepared in accordance with the method described in Example 4. The as prepared film WO₃ was further subjected to an annealing step at 200° C. and an annealing step at 600° C. (Annealing performed in air for 1 hr). The resulting films were characterized and the AT, $t_{b,90\%}$, and $t_{c,90\%}$ and CE values of devices assembled are provided in FIG. **19**: (a) as-prepared WO₃; (b) WO₃ annealed at 200° C.; and (c) WO₃ annealed at 600° C.

TABLE 2

Performance parameters as a function of annealing temperatures of
the active layer for devices assembled with photo-deposited WO ₂ .

annealing temperature (° C.)	ΔT (%)	$\operatorname*{t_{c,90\%}}_{(s)}$	$^{\rm t_{\it b,90\%}}_{\rm (s)}$	CE (cm ² /C)
as-prepared	60	15	4	92
100	70	12	5	133

the active layer for devices assembled with photo-deposited WO3.

Performance parameters as a function of annealing temperatures of

annealing temperature (° C.)	ΔT (%)	t _{c,90%} (s)	t _{b,90%} (s)	CE (cm ² /C)
200	66	14	6	131
400	56	68	166	69
600	42	101	109	69

"Device active layers are \sim 600 nm (5 successive layers of deposition). Operational potentials for the colored and bleached forms were -3.5 and +3.0 V. Optical data was measured at 700 nm. Values for Δ T, $t_{c,90\%}$, $t_{b,90\%}$ and CE are also shown in FIG. 19.

Example 7: Effect of WO₃ Film Thickness on Electrochromic Performance

The electrochromic performance of a-WO $_3$ at different thicknesses was evaluated to determine how performance is affected by film thickness by successively adding up to 10 layers of films (Table 3). The ΔT values at 700 nm increases from 29% to 70% from 1-5 layers, respectively. Although additional layers led to darker coloration, they did not benefit the optical modulation, which was reduced to 62% with 10 layers, because of the compromised transparency of the thicker layers. Moreover, switching times and CE values were both found to be inversely proportional to film thickness. The coloring and bleaching times of 2 s observed for one layer increased to >20 s for 10 layers, while a coloration efficiency of 193 cm²/C decreased to 117 cm²/C with 10 layers.

TABLE 3

Performance parameters a	s a function of active
layer thickness for devices asser	nbled with photo-deposited
WO ₂ annealed at 10	0° C. for 1 hr."

# layers ^b	ΔT (%)	$^{\rm t_{c,90\%}}_{\rm (s)}$	$^{\rm t_{\it b,90\%}}_{\rm (s)}$	CE (cm ² /C)
1	29	2	2	193
3	55	9	3	153
5	70	12	5	133
7	68	28	13	118
10	62	24	23	117

^aColored and bleached states produced at -3.5 and +3.0 V, respectively. Optical data measured at 700 nm. Values for AT, t_{0.90%}, t_{0.90%} and CE are also shown in FIG. 25. ^bSEM cross-sectional imaging verified film thicknesses of 200 and 600 nm for 1 and 5 layers, respectively.

Example 8: WO₃ NIRDD

In this example, the transparent conductive oxide is prepared in the same manner as Example 1. Anhydrous ethanol is added to tungsten (VI) chloride (WCl₆, Sigma-Aldrich) to make a 0.25 M solution. This solution is stirred for 16 hours and spin-coated onto a substrate (3000 rpm, 60 s) yielding a dark blue film on the substrate. The substrate is then placed under an IR lamp for decomposition of the 55 precursor to form a-WO₃, and transformation to the metal oxide is monitored by X-ray fluorescence. The amorphous or crystalline phase can be obtained through annealing after the conversion to the oxide. The electrochromic devices were assembled as described in Example 3.

Example 9: $LiNiO_x$ and Other Mixed Metal Compositions by UV Photodecomposition or NIRDD

In this example, the transparent conductive oxide was prepared in the same manner as Example 1. A $0.2\,M$ solution

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of nickel (II) 2-ethylhexanoate (78% (w/w) in 2-ethylhexanoic acid, Strem Chemicals) and lithium 2-ethylhexanoate (Strem Chemicals) was prepared in hexanes with varying ratios of Li:Ni, for example 25:75, 40:60, 50:50, 75:25. The solution is applied to the TCO substrate and spin-coated onto a substrate (3000 rpm, 60 s). The precursors are decomposed under either a UV lamp (I=185 or I=185, 254 nm) or an IR lamp to form a-LiNiO_x.

Transformation to the metal oxide was monitored as in Example 1. The electrochromic devices were assembled as described in Example 3.

Example 10: V₂O₅ UV Photodecomposition

In this example, the transparent conductive oxide was prepared in the same manner as Example 1. Anhydrous ethanol was added to vanadium (111) chloride (VCl₃, Sigma-Aldrich) to make a 0.25 M solution. This solution was stirred for 16 hours and spin-coated onto a substrate (3000 rpm, 60 s) yielding a dark blue film on the substrate. The substrate was then placed under a UV lamp (I=185 or I=185, 254 nm) for decomposition of the precursor to form a-V₂O₅. Transformation to the metal oxide was monitored as in Example 4.

FIG. 13a depicts a plot of the chlorine content for vanadium chloride precursor film on FTO glass as a function of irradiation time, as measured by XRF analysis, and confirmed complete decomposition of the precursor after 10 min of irradiation. FIGS. 13b and 13c show that the XPS analysis of the metal oxide films on FTO glass is consistent with the formulation of as-prepared V_2O_5 on FTO glass. FIG. 13c is an expanded XPS spectrum featuring $V2p_{1/2}$ and $V2p_{3/2}$ signals at 525.40 eV and 517.85 eV, respectively, that are diagnostic of V^{5+} . FIG. 13d is an IR spectra of an ethanolic solution of VCl_5 spin-cast on FTO glass before (fresh) and after (photolyzed) being subjected to UV irradiation for 10 min. The as-prepared oxide film annealed at 100° C. for 1 hr is also indicated (annealed) in FIG. 13d.

Example 11: V_2O_5 NIRDD

In this example, the transparent conductive oxide is prepared in the same manner as Example 1. Anhydrous ethanol is added to vanadium (III) chloride (VCl₃, Sigma-Aldrich) to make a 0.25 M solution. This solution is stirred for 16 hours and spin-coated onto a substrate (3000 rpm, 60 s) yielding a dark blue film on the substrate. The substrate is then placed under an IR lamp for decomposition of the precursor to form a-V₂O₅, and transformation to the metal oxide is monitored by X-ray fluorescence. The amorphous or crystalline phase can be obtained through annealing after the conversion to the oxide. The electrochromic devices were assembled as described in Example 3.

Example 12: Nb₂O₅ UV Photodecomposition

In this example, the transparent conductive oxide was prepared in the same manner as Example 1. Anhydrous ethanol was added to niobium (V) chloride (NbCl₅, Sigma-60 Aldrich) to make a 0.25 M solution. This solution was stirred for 16 hours and spin-coated onto a substrate (3000 rpm, 60 s) yielding a dark blue film on the substrate. The substrate was then placed under either a UV lamp (I=185 or I=185, 254 nm) for decomposition of the precursor to form a-Nb₂O₃. Transformation to the metal oxide was monitored as in Example 4. The electrochromic devices were assembled as described in Example 3.

FIG. 15a depicts a plot of the chlorine content for niobium chloride precursor film on FTO glass as a function of irradiation time, as measured by XRF analysis, and confirmed complete decomposition of the precursor after 10 min of irradiation. FIGS. 15b and 15c show that the XPS analysis of the metal oxide films on FTO glass is consistent with the formulation of as-prepared Nb₂O₅ on FTO glass. FIG. 15c is an expanded XPS spectrum featuring Nb3d_{3/2} and Nb3d_{5/2} signals at 210.10 eV and 207.40 eV, respectively, that are diagnostic of Nb⁵⁺. FIG. 15d is an IR spectra of an ethanolic solution of NbCl₅ spin-cast on FTO glass before (fresh) and after (photolyzed) being subjected to UV irradiation for 10 min. The as-prepared oxide film annealed at 100° C. for 1 h is also indicated (annealed) in FIG. 15d.

Example 13: Nb₂O₅ NIRDD

In this example, the transparent conductive oxide is prepared in the same manner as Example 1. Anhydrous ethanol is added to niobium (V) chloride (NbCl $_5$, Sigma-Aldrich) to make a 0.25 M solution. This solution is stirred for 16 hours and spin-coated onto a substrate (3000 rpm, 60 s) yielding a dark blue film on the substrate. The substrate is then placed under an IR lamp for decomposition of the precursor to form a-Nb $_2$ O $_3$, and transformation to the metal 25 oxide is monitored by X-ray fluorescence. The amorphous or crystalline phase can be obtained through annealing after the conversion to the oxide. The electrochromic devices were assembled as described in Example 3.

Example 14: MoO₃ UV Photodecomposition

In this example, the transparent conductive oxide was prepared in the same manner as Example 1. Anhydrous ethanol was added to molybdenum (V) chloride (MoCl₅, ³⁵ Sigma-Aldrich) to make a 0.25 M solution. This solution was stirred for 16 hours and spin-coated onto a substrate (3000 rpm, 60 s) yielding a dark blue film on the substrate. The substrate was then placed under either a UV lamp (I=185 or I=185, 254 nm) or an IR lamp for decomposition ⁴⁰ of the precursor to form a-MoO₃. Transformation to the metal oxide was monitored as in Example 4. The electrochromic devices were assembled as described in Example 3.

FIG. 17a depicts a plot of the chlorine content for molybdenum chloride precursor film on FTO glass as a 45 function of irradiation time, as measured by XRF analysis, and confirmed complete decomposition of the precursor after 30 min of irradiation. FIGS. 17b and 17c show that the XPS analysis of the metal oxide films on FTO glass is consistent with the formulation of as-prepared MoO₃ on 50 FTO glass. FIG. 17c is an expanded XPS spectrum featuring Mo3d_{3/2} and Mo3d_{5/2} signals at 236.28 eV and 233.15 eV, respectively, that are diagnostic of Mo⁶⁺. FIG. 17d is an IR spectra of an ethanolic solution of MoCl₅ spin-cast on FTO glass before (fresh) and after (photolyzed) being subjected to 55 UV irradiation for 30 min. The as-prepared oxide film annealed at 100° C. for 1 h is also indicated (annealed) in FIG. 17d.

Example 15: MoO₃ NIRDD

In this example, the transparent conductive oxide is prepared in the same manner as Example 1. Anhydrous ethanol is added to molybdenum (V) chloride (MoCl₅, Sigma-Aldrich) to make a 0.25 M solution. This solution is 65 stirred for 16 hours and spin-coated onto a substrate (3000 rpm, 60 s) yielding a dark blue film on the substrate. The

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substrate is then placed under an IR lamp for decomposition of the precursor to form a-MoO $_3$, and transformation to the metal oxide is monitored by X-ray fluorescence. The amorphous or crystalline phase can be obtained through annealing after the conversion to the oxide. The electrochromic devices were assembled as described in Example 3.

Example 16: Use of Amorphous TiO₂ as an Ion Storage Material in an EC Device

Amorphous TiO₂ films were produced using the solution-based photodeposition methods of the present invention. To form the TiO₂ film, 155 mg Ti(IV) 2-ethylhexanoate were dissolved in 1 mL HPLC-grade isopropanol yielding a 0.25 M solution. This solution was pipetted onto a FTO-coated glass substrate and spun cast at 3000 rotations per minute for 1 minute (Laurell model WS-650MZ-23NPP-Lite). The resultant precursor films were subjected to 10 minutes of UV (Atlantic Ultraviolet G18T5VH/U; Imax=185) irradiation.

The films were annealed in an oven (Ney Vulcan 3-550) in air at different temperatures for 1 h with a ramping rate of 10° C./min. The WO₃ films were produced by the same procedures except that 0.22 M WCl₆ isopropanol solution were used as the precursor solution and UV irradiation time 25 was 5 min.

The resulting amorphous TiO₂ film can be crystallized to anatase TiO₂ (JCPDS 021-1272) at 400° C. The crystalline TiO₂ film displays an almost identical morphology to amorphous films, with a thickness of about 60 nm, slightly thinner than amorphous films.

FIG. 24a is a schematic depiction of an EC device employing TiO_2 as an ion storage material and WO₃ as the electrochromic layer. The EC device was assembled using the same method described in Example 3.

FIG. **24***b* depicts the maximum and minimum transmittance at wavelength of 700 nm over 1000 cycles for EC devices with WO₃ as the electrochromic layer, a-TiO₂ (light grey) and crystalline c-TiO₂ (dark grey) deposited on FTO as the counter electrode, to be further compared to bare FTO (black). For each cycle, the device was coloured at -3.5 V for 30 s and subsequently bleached at +3.0 V for another 30 s. As shown in FIG. **24***b*, the EC device with a TiO₂ coating as the counter electrode showed enhanced cycling stability compared to a device using bare FTO. This may be due a protective effect provided by the thin layer of TiO₂ film on FTO, which protect the crystalline FTO substrate from degradation, as shown by the retention of low internal resistance of the device using a-TiO₂ at the counter electrode after cycling 1000 times (Table 4).

TABLE 4

Internal resistance^a across the electrodes of the EC device before and after cycling for devices with FTO and a-TiO₂ on FTO as the counter electrode

Counter electrode	Resistance before cycling (Ω)	Resistance after 1000 cycles (Ω)
FTO	35	378
a-Ti O_2 on FTO	32	33

60 aThe resistance was measured by iR compensation

Example 17: Preparation of a Solid State Electrochromic Device

The WO_3 and NiO_x films were synthesized by slight modification of the previously reported method.

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To prepare the WO₃ film for use in the solid state EC device, a precursor solution prepared by dissolving 0.4 g WCl₆ in 4 ml 2-propanol (0.25 M) was spin-coated on FTO glass at 3000 rpm for 60 s (Laurell model WS-650MZ-23NPP-Lite). The resultant precursor thin films were subjected to UV (Atlantic Ultraviolet G18T5VH/U; λ_{max} =185) irradiation until complete decomposition was confirmed by monitoring the chlorine content using XRF analysis.

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To prepare the NiO_x film for use as an ion storage material in the solid state EC device, a NiCl_2 aqueous solution (0.25 M) was used as precursor solution and the remaining procedures remain the same as for the preparation of the WO₃ film. FIG. **21***a* is a schematic illustration showing UV light irradiation of spin-casted NiCl_2 precursor films on FTO glass lead to formation of amorphous NiO_x (a- NiO_x).

Analysis of the resulting a-NiO_x film is depicted in FIGS. **21***b* to **21***d*. FIG. **21***b* depicts a plot of the chlorine of CI in precursor film determined by XRF analyzer as a function of UV irradiation time, and confirm that chloride ions are completely removed by UV light in 8 hours. FIG. **21***c* is an 20 XPS spectra of NiCl₂ precursor and as-formed NiO_x in binding energy range corresponding to Cl 2p. No Cl 2p signal appears in as-formed NiO_x, confirming fully decomposition of chloride ions in by UV irradiation. FIG. **21***d* is an XPS spectrum of NiO_x in the binding energy range corresponding to Ni 2p, matching well with that of Ni²⁺.

To prepare the electrolyte for use in the solid state device, LiClO₄ and PMMA were dried in an oven at 100° C. for overnight. Propylene carbonate (PC) was dried overnight by adding Molecular Sieve Type-3A with a w/v of 20%. The 30 molecular sieves were activated before use by annealing at 300° C. for overnight. 0.532 g LiClO₄ was dissolved in 10 ml propylene carbonate to form a 0.5 M solution. 1.339 g PMMA was then added to the LiClO₄—PC solution under magnetic stirring. The mixtures were stirred and heated at 35 60° C. on a hot plate for overnight to form a transparent colorless gel electrolyte.

Prior to assembly of the device, prelithiation of NiO_x films was carried out in a 1 M-LiClO₄ propylene carbonate electrolyte using a conventional three electrode system with 40 NiO_x films on FTO glass as working electrode, Ag/AgCl as reference electrode, and Pt wire as counter electrode. The lithium ions were injected into NiO_x by applying a potential of -1.5 V (vs Ag/AgCl) for 10 min. Electrochromic devices were fabricated by placing a 2×2 cm square silicone rubber 45 sheet (50 A, thickness=1 mm; McMaster-CARR) with a centered hollow circle (diameter=1.6 cm) on top of prelithiated NiO_x film on FTO glass that serves as the counter electrode. A gel electrolyte of LiClO4-PC-PMMA was then drop-casted into the hollow circle. FTO glass was then 50 coated with the WO₃ films (working electrode) laid on top the silicon spacer to form a closed cell. Epoxy glue was used

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to seal the cell. The assembled device had an active area of 2.0 cm². The assembled devices were heated at 60° C. in an oven for overnight before property characterization.

FIG. **22**a is a schematic depiction of the architecture of a solid state EC device using an NiO_x film on the FTO glass counter electrode as an ion storage material.

FIG. 22b shows a comparison of the transmittance spectra obtained for EC devices prepared with and without a-NiO $_x$ on the FTO glass counter electrode at bleached and colored state. The spectra were recorded after coloring at -2.1 V or bleaching at +2.1 V for 60 s.

FIG. 22c shows the transmittance change at wavelength of 633 nm for the EC device prepared with a-NiO_x on FTO as counter electrode as a function of time. The device was bleached at +2.1 V for 30 s, then colored at -2.4 V for another 30 s. Switch times are indicated.

FIG. **22***d* shows changes in optical density at 633 nm as a function of charge density for a solid state EC device prepared using a-NiO_x on the FTO glass counter electrode.

Example 18: Comparison of Solid State EC Devices Prepared Using Amorphous and Crystalline NiO as Counter Electrodes

FIG. 23a shows a comparison of transmittance spectra of EC devices prepared using a-NiO_x and c-NiO films prepared using the present methods as counter electrodes at colored and bleached state. The spectra were recorded after coloring at -2.1 V and bleaching at +2.1 V for 60 s. FIG. 23b depicts the transmittance change at wavelength of 633 nm for the EC devices with a-NiO_x and c-NiO on FTO as counter electrode as a function of time. The devices were bleached at +2.1 V for 30 s, then colored at -2.1 V for another 30 s. Switch times are indicated. FIG. 23c depicts the changes in optical density of the respective devices at 633 nm as a function of charge density using a-NiO_x and c-NiO on FTO as counter electrode. Coloration efficiency values were determined by fitting the linear region of the plot.

Example 19: Comparison of Solid State Devices of the Present Invention with Prior Art Devices

All devices listed in Table 5 use WO₃ films as electrochromic layers, NiO films as ion storage layer, and polymerbased electrolyte. The present work clearly demonstrates that the amorphous NiO films formed in accordance with the present invention show superior performance to its crystalline counterpart, which has never been previously documented. The methods of the present invention also represent a significant advancement towards using solution-processing methods for deposition of metal oxide films for use in solid state electrochromic windows.

TABLE 5

Performance parameters of our solid state electrochromic devices in comparison to that of solid-state devices reported in the literatures								
Counter electrode material	Phase	Deposition method	ΔT ^a (%)	$t_{c,90\%}^{\ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ $	$t_{b,90\%}^{\ c}$ (s)	CE ^d (cm ² /C)	Reference	
NiO porous film	crystalline	chemical bath deposition	55%	10	20	87.2	Zhang et al.e	
NiO nanoparticle film	crystalline	inkjet printing	75%	10	13	131.9	Cai et al.f	
NiO_{x} film	crystalline	magnetron	52%	5	2	_	Liu et al. g	

sputtering

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comparison to that of solid-state devices reported in the literatures							
Counter electrode material	Phase	Deposition method	ΔT^a (%)	${\rm t_{c,90\%}}^b_{\rm (s)}$	t _{b,90%} c (s)	CE^d (cm ² /C) Reference	
NiO film NiO film	amorphous crystalline	UV UV	60% 26%	4 78	6 17	141.1 this work ^h 72.0 this work ^h	

Example 20: Photodeposition of Electrochromic Films on Tin-Doped Indium Oxide (ITO) Coated Polyethylene Terephthalate (PET)

The methods of the present invention have also been demonstrated as useful for deposition of metal oxide films on flexible substrates.

A precursor solution was prepared by rotary evaporating 4 ml of tungsten(VI) isopropoxide 5% w/v in isopropanol to approximately 2 ml. Then, 0.152 ml acetylacetone was added to the tungsten(VI) isopropoxide solution. After 30 min, the precursor solutions were spin-coated onto ITO-PET 30 substrates at 3000 rpm for 60 s (Laurell model WS-650MZ-23NPP-Lite). The resultant precursor thin films were subjected to UV (Atlantic Ultraviolet G18T5VH/U; λ_{max} =185) irradiation until complete decomposition of organic ligands confirmed by FTIR analyses. To produce multi-layer thin 35 films, the spin-coating and UV light irradiation steps were repeated multiple times. The as-deposited films were annealed in an oven (Ney Vulcan 3-550) in air at 100° C. for 1 hour.

The electrochromic properties were measured in a spec- 40 troelectrochemical cell that has a three electrodes configuration. WO₃ film on ITO-PET was used as working electrode, Ag/AgCl as reference electrode, and Pt as counter electrode. 1 M-LiClO₄ propylene carbonate was used as electrolyte. The optical properties were recorded by Perki- 45 nElmer Lambda 35 UV-Vis spectrophotometer. The potentials were applied by a CHI660D potentiostat.

FIG. 26a shows the transmittance spectra of coloured and bleached WO₃ on ITO-coated PET plastic substrate after holding the potential at -/+0.7 V (vs Ag/AgCl) for 60 50 seconds. The photographs are the photodeposited WO₃ film on ITO-PET substrate at bleached and colored states.

FIG. 26b shows the transmittance change at 700 nm as a function of time. The WO₃ film was held at potential of +0.7 V for 30 s and followed by another 30 seconds at -0.7 V. 55 Switching times are indicated.

Example 21: Effect of Nb Doping on WO₃ Film Performance

For the synthesis of WO₃ film, a 0.25 M WCl₆ isopropanol precursor solution was prepared by dissolving 0.200 g WCl₆ in 2 ml of 2-propanol. The precursor solution for the 10% Nb-doped WO₃ was prepared by adding 0.43 ml of the 0.1 M NbCl₅ ethanol solution into 1.57 ml of 0.25 M WCl₆ 65 isopropanol solution. The precursor solutions were then spin-coated on FTO glass at 3000 rpm for 60 s (Laurell

model WS-650MZ-23NPP-Lite). The resultant precursor thin films were subjected to UV (Atlantic Ultraviolet G18T5VH/U; λ_{max} =185) irradiation for 15 min. To produce multi-layer thin films, the spin-coating and UV light irradiation steps were repeated multiple times. The as-deposited films were annealed in an oven (Ney Vulcan 3-550) in air at 100° C. for 1 hour.

The electrochromic properties were measured in a spectroelectrochemical cell that has a three electrodes configuration. Doped or undoped WO₃ film on FTO glass was used as working electrode, Ag/AgCl as reference electrode, and Pt as counter electrode. 1 M-LiClO₄ propylene carbonate was used as electrolyte. The optical properties were recorded by PerkinElmer Lambda 35 UV-Vis spectrophotometer. The potentials were applied by a CHI660D potentiostat.

FIG. 26a shows a comparison of the transmittance spectra for undoped WO3 (black) and Nb-doped WO3 (grey) on FTO glass after holding the potential at -0.8 V (coloring) and -0.8 V (bleaching) (vs Ag/AgCl) for 60 seconds. FIG. 26b shows a comparison of the tansmittance change as a function of time over 10 electrochromic cycles for undoped WO₃ (black) and Nb-doped WO3 (grey). In each cycle the films were held at -0.8 V (vs Ag/AgCl) for 30 seconds followed by another 30 seconds at +0.8 V.

Example 22: Effect of Ti Doping on WO₃ Film Performance

A 0.25 M WCl₆ isopropanol precursor solution was prepared by dissolving 0.200 g WCl₆ in 2 ml 2-propanol. A 0.25 M Ti(IV) 2-ethylhexanoate precursor solution was prepared by dissolving 0.282 g Ti (IV) 2-ethylhexanoate in 2 ml 2-propanol. The precursor solutions for the 1%, 5%, 10% Ti-doped WO₃ were prepared by mixing 0.02 ml, 0.10 ml, and 0.20 ml 0.25 M Ti(IV) 2-ethylhexanoate isopropanol solutions with 1.98 ml, 1.9 ml, and 1.8 ml 0.25 M WCl₆ isopropanol solutions respectively. The precursor solutions were then spin-coated on FTO glass at 3000 rpm for 60 s (Laurell model WS-650MZ-23NPP-Lite). The resultant precursor thin films were subjected to UV (Atlantic Ultraviolet G18T5VH/U; λ_{max} =185) irradiation for 10 min. To produce multi-layer thin films, the spin-coating and UV light irradiation steps were repeated multiple times. The as-deposited films were annealed in an oven (Ney Vulcan 3-550) in air at 100° C. for 1 hour.

The electrochromic properties were measured in a spectroelectrochemical cell that has a three electrodes configuration. Doped or undoped WO3 film on FTO glass was used as working electrode, Ag/AgCl as reference electrode, and Pt as counter electrode. 1 M-LiClO₄ propylene carbonate was used as electrolyte. The optical properties were recorded

[°]Maximum optical modulation (Δ T) determined by the light transmittance difference between fully colored and bleached states at a specific wavelength °Switching time of coloring ($t_{e,90\%}$) defined by the time required to reach 90% of a full transmittance change from the bleached to colored state. °Switching time of bleaching ($t_{b,90\%}$) from the colored to bleached state.

dColoration efficiency (CE) defined as the change in optical density acquired by injection of charge per unit area

eMeasured in a potential range from -2.5 V to +2.5 V, at wavelength of 633 nm

⁵Measured in a potential range from -2.5 V to +2.5 V, at wavelength of 550 nm

^hMeasured in a potential range from -1.8 V to +1.8 V, at wavelength of 550 nm

^hMeasured in a potential range from -2.1 V to +2.1 V, at wavelength of 633 nm

by PerkinElmer Lambda 35 UV-Vis spectrophotometer. The potentials were applied by a CHI660D potentiostat.

FIG. 27 depicts the maximum and minimum transmittance over 1000 cycles for undoped and Ti-doped WO_3 films. In each cycle the films were held at -0.8~V (vs Ag/AgCl) for 30 seconds followed by another 30 seconds at +0.8~V.

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What is claimed:

- 1. A process for forming an electrochromic material suitable for use in an electrochromic device, the process comprising:
 - providing a transparent conductive substrate;
 - coating the transparent conductive substrate with a solution of one or more metal precursors, wherein a metal precursor comprises a ligand selected from chloride, bromide and nitrate and is converted to a metal oxide upon exposure to UV radiation and/or ozone; and
 - exposing the coated transparent conductive substrate to UV radiation and/or ozone in an aerobic atmosphere at ambient temperature and ambient pressure to effect conversion of the one or more metal precursors to a metal oxide film on the transparent conductive substrate without application of a heat treatment with an external heat source, thereby forming the electrochromic material.
 - wherein the electrochromic device comprises:
 - a first electrode comprising the electrochromic material
 - a counter electrode, and
 - an ion-conductor layer for conducting ions between the first electrode and the counter electrode.
- 2. The process according to claim 1, further comprising annealing the metal oxide film, wherein annealing is carried out at a temperature of about 50° C. to about 750° C.
- 3. The process according to claim 1, further comprising annealing the metal oxide film, wherein the annealing is carried out at about 100° C., 200° C. or 600° C. for 1 hour.
- 4. The process according to claim 1, wherein the metal oxide film comprises a metal oxide selected from the group consisting of NiO_x, WO_x, NbO_x, MoO_x, MnO_x, CoO_x, VO_x, TaO_x, TiO_x, FeO_x, IrO_x, and combinations thereof, a mixed metal oxide selected from LiNiO_x, TiWO_x, and FeNiO_x, or a doped metal oxide selected from Nb doped WO₃ and Ti doped WO₃.
- 5. The process according to claim 4, wherein the metal oxide film comprises WO3.
- 6. The process according to claim 1, wherein the transparent conductive substrate is formed of a conductive material
- 7. The process according to claim 1, wherein the transparent conductive substrate is formed of a transparent material coated with a conductive film.
- **8**. The process according to claim **7**, wherein the transparent conductive substrate is a substrate coated with fluorine tin oxide (FTO), indium tin oxide (ITO), or aluminum zinc oxide (AZO).
- 9. The process according to claim 1, wherein coating and exposing are repeated until a desired thickness of the metal oxide film is achieved.

- 10. The process according to claim 1, wherein the metal oxide film is an amorphous metal oxide film.
- 11. The process according to claim 1, wherein the metal oxide film is a crystalline metal oxide film.
- 12. The process according to claim 1, wherein the first 5 electrode comprises FTO glass coated with an amorphous WO₃ film.
- 13. The process according to claim 1, wherein the counter electrode comprises bare FTO glass.
- 14. The process according to claim 1, wherein the metal 10 oxide film is a first metal oxide film and the counter electrode comprises FTO glass coated with a second metal oxide film prepared using the process as defined in claim 1.
- 15. The process according to claim 14, wherein the counter electrode comprises FTO glass coated with ${\rm NiO}_x$ or 15 ${\rm TiO}_x$.
- **16**. The process according to claim **1**, wherein the ion-conductor layer is an electrolytic solution.
- 17. The process according to claim 16, wherein the electrolytic solution is a $LiClO_4$ -propylene carbonate electrolyte solution.
- 18. The process according to claim 1, wherein the electrochromic device is a solid-state device and the ion-conductor layer is an electrolytic gel.
- 19. The process according to claim 18, wherein the 25 ion-conductor layer is LiClO₄-propylene carbonate-poly (methyl methacrylate) gel electrolyte.
- **20**. The process according to claim **7**, wherein the transparent conductive substrate is indium tin oxide (ITO) coated polyethylene terephthalate (PET).

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